



IFW

XA-9897
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Fujiaki NOSE et al.

Appln. No.: 10/621,411

Group Art Unit: 2815

Filed: July 18, 2003

Examiner: A. Wilson

For: A SEMICONDUCTOR DEVICE AND A METHOD OF MANUFACTURING
THE SAME

* * *

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Responding to the Office Action mailed September 29, 2004, and to the requirement for restriction therein, Applicants elect Group I (Claims 1-7) without traverse, reserving the right to file a divisional application with regard to the non-elected invention.

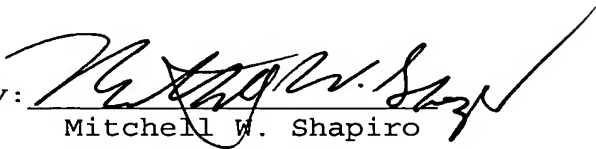
An action on the merits of the claims to the elected invention is respectfully requested.

The Commissioner is hereby authorized to charge to Deposit Account No. 50-1165 any fees under 37 C.F.R. §§1.16 and 1.17 which may be required by this paper, and to credit

any overpayment to that Account. If any extension of time is required in connection with the filing of this paper and has not been requested separately, then such extension is hereby requested.

Respectfully submitted,

By:


Mitchell W. Shapiro
Reg. No. 31,568

MWS:lat

Miles & Stockbridge P.C.
1751 Pinnacle Drive
Suite 500
McLean, Virginia 22102
(703) 903-9000

October 29, 2004